



PATENT
1794-0141P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Yoshinobu AOYAGI et al. Conf.: 6758
Appl. No.: 09/941,612 Group: 1765
Filed: August 30, 2001 Examiner: UNKNOWN
For: IMPURITY DOPING METHOD FOR SEMICONDUCTOR
AS WELL AS SYSTEM THEREFOR AND
SEMICONDUCTOR MATERIALS PREPARED THEREBY

RECEIVED

NOV 26 2001

LETTER

TC 1700

Assistant Commissioner for Patents
Washington, DC 20231

November 19, 2001

Sir:

Enclosed herewith is a Supplemental Declaration that should be made part of the record of the present application.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fee required under 37 C.F.R. §§ 1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By Joe McKinney Muncy, #32,334

KM/ghh
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Attachment